



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul J. Farrar

Title: CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS

Docket No.: 1303.018US1

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Examiner: Maurina Rachuba

Group Art Unit: 3723

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ A return postcard.

☒ Response Under 37 CFR 1.111 (23 Pages).

If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

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By: 

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17 day of November, 2004.

Name

KACIA LEE

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(GENERAL)

